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**EXPEDITED PROCEDURE**

**APR 13, 2006** Examining Group Number 2800

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Craig K. Carlson-Stevemer

Examiner: Jermele M. Hollington

Serial No.: 10/622,849

Group Art Unit: 2829

Filed: July 18, 2003

Docket No.: A126.114.102

Due Date: April 14, 2006

Title: WAFER STAGING PLATFORM

**AMENDMENT AND RESPONSE UNDER 37 C.F.R. 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This Amendment and Response is in reply to the Final Office Action mailed February 14, 2006. Please amend the above-identified patent application as follows:

*Please  
enter  
JmH*

*4/27/06*